

L Number	Hits	Search Text	DB	Time stamp
1	1	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and (loop with power with ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:08
2	24	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power with ground) and loop	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:12
3	1373	loop with power with (GND ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:13
4	1676	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:12
5	1	(loop with power with (GND ground)) and (((MIM (metal near insulat\$3 near metal)) near capacitor\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:12
6	409	loop near5 power near5 (GND ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:12
7	0	(loop near5 power near5 (GND ground)) and (((MIM (metal near insulat\$3 near metal)) near capacitor\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:14
8	2701	loop with (source power potential) with (GND ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:16
9	6	(loop with (source power potential) with (GND ground)) and (((MIM (metal near insulat\$3 near metal)) near capacitor\$1)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:15
10	1	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1))) and (loop near (shape\$1 configur\$6))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:16
11	216805	(source power potential) with (GND ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:17
12	1281	((source power potential) with (GND ground)) and (loop near (shape\$1 configur\$6))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:17

13	106331	((power near source) potential) with (GND ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:17
14	670	((((power near source) potential) with (GND ground)) and (loop near (shape\$1 configur\$6)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:19
15	481	(((((power near source) potential) with (GND ground)) and (loop near (shape\$1 configur\$6)))) and (electrode wir\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:18
16	1	((((power near source) potential) with (GND ground)) and (loop near (shape\$1 configur\$6) near2 around near2 (IC circuit)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:22
17	0	((power near source) potential) with (GND ground) with (loop near (shape\$1 configur\$6) near2 around near2 (IC circuit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:22
18	1	(((((power near source) potential) with (GND ground)) and (loop near (shape\$1 configur\$6)))) and (loop near (shape\$1 configur\$6) near2 around near2 (IC circuit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:22
19	3	(loop near (shape\$1 configur\$6) near2 around near2 (IC circuit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:23
20	7	(loop near (shape\$1 configur\$6) with around near2 (IC circuit))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:23
-	0	"2001" near "102529"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 15:54
-	3	"2001102529"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 15:56
-	405421	257/\$.ccls. 438/\$.ccls. 365/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 15:57
-	3576	(257/\$.ccls. 438/\$.ccls. 365/\$.ccls.) and (MIM (metal near insulat\$3 near metal))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 15:58

-	830	(257/\$.ccls. 438/\$.ccls. 365/\$.ccls.) and ((MIM (metal near insulat\$3 near metal)) near capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:33
-	42	((257/\$.ccls. 438/\$.ccls. 365/\$.ccls.) and ((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power with ground)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:33
-	14	("4455568" "5032892" "5079609" "5212402" "5266821" "5366931" "5656834" "5668399" "5932905" "5940676" "5955758" "5972791" "5973908" "6034391").PN.	USPAT	2004/07/29 16:12
-	14	("4598307" "4737830" "4864464" "4929989" "4937649" "5200364" "5482897" "5590017" "5598029" "5629240" "5652693" "5730835" "5780930" "5834348").PN.	USPAT	2004/07/29 16:14
-	1	"5351163".PN.	USPAT	2004/07/29 16:27
-	4	("4267633" "4683384" "4764723" "4926234").PN.	USPAT	2004/07/29 16:31
-	1676	((MIM (metal near insulat\$3 near metal)) near capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:20
-	1	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power with ground with (connect\$3 near (wir\$3 metal layer))))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:35
-	91	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power with ground))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/30 12:09
-	4	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with (power near source) with ground	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:53
-	12	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with (connect\$3 near wir\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:57
-	26	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with ((connect\$3 interconnect\$3) near wir\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 16:55
-	77	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and (connect\$3 near wir\$3)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 17:06
-	1212	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and electrode\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:29
-	539	((((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and electrode\$1) and via\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:29

-	530	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and electrode\$1) and via\$1) and (insulat\$3 dielectric)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:29
-	32	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and electrode\$1) and via\$1) and (insulat\$3 dielectric)) and ((source ground) near potential\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 17:17
-	137	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) and electrode\$1) and via\$1) and (insulat\$3 dielectric)) and potential\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:30
-	1767	(power near source near2 (potential wir\$3 layer)) with (ground near (potential wir\$3 layer))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:12
-	2	((power near source near2 (potential wir\$3 layer)) with (ground near (potential wir\$3 layer))) and (((MIM (metal near insulat\$3 near metal)) near capacitor\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:12
-	42	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power near source) and ground	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:21
-	1878	((MIM (metal near insulat\$3 near metal)) near2 capacitor\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:21
-	46	(((MIM (metal near insulat\$3 near metal)) near2 capacitor\$1)) and (power near source) and ground	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:26
-	2	("5194932").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:27
-	685	((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with electrode\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:29
-	659	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with electrode\$1) and (insulat\$3 dielectric)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:29
-	283	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with electrode\$1) and (insulat\$3 dielectric)) and via\$1	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:30

-	156	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1) with electrode\$1) and (insulat\$3 dielectric)) and via\$1) and (voltage\$1 potential\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 18:31
-	1	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power near source near noise)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 19:04
-	222	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and noise	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 19:03
-	32	(((MIM (metal near insulat\$3 near metal)) near capacitor\$1)) and (power near2 noise)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/07/29 19:04